



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: S. H. Rao

Filed: October 7, 1997

Docket No.: 039514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE
FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

AMENDMENT SUBMISSION UNDER 37 CFR §1.114

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the March 31, 2004 Final Office Action, and in view of the attached

Request for Continued Examination, please consider the following:

Amendments to the Claims are reflected in the listing of claims; and

Remarks.